

Supporting Information

Wet-spun, Porous, Orientational Graphene Hydrogel Films for High-performance Supercapacitor Electrodes

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Figure S1 The schematic diagram for fabricating graphene oxide hydrogel film (A) and digital photo of line-shape flat nozzle (B).

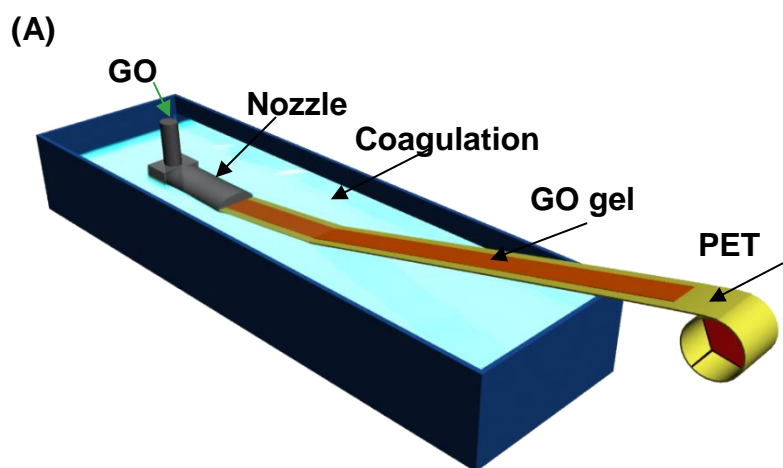


Figure S2 The digital photo of the test device for two-electrode system.



Figure S3 Typical stress-strain curves of GHF-HT, GHF-HZ and GHF-HI.

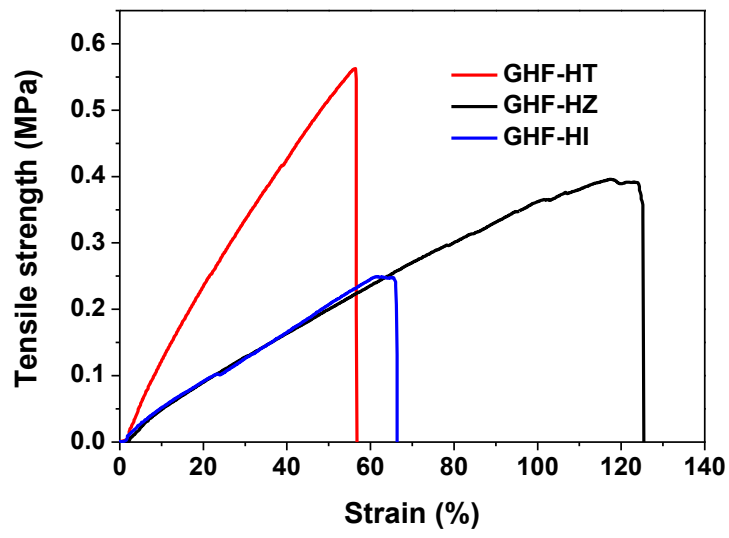


Figure S4 TGA curves of GHF-HT, GHF-HZ and GHF-HI.

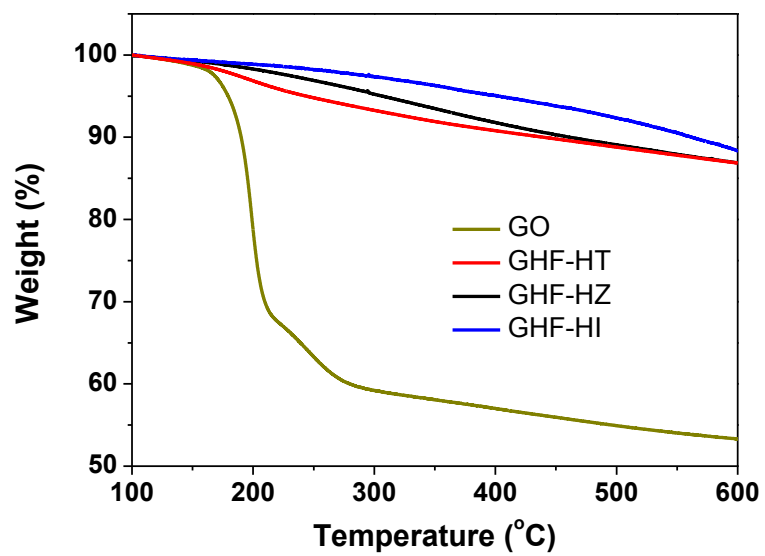


Table S1 Comparison of electrochemical performance of our GHF-HZ supercapacitors (yellow column) with supercapacitors using graphene hydrogel electrodes.

Preparation method	Current density (A/g)	Specific capacitance (F/g) of literature	GHF-HZ in this work (F/g)
GO, L-glutathione, 95°C ^[1]	1	157.7	203
	10	92	188
GO, ascorbic acid, 180°C ^[2]	1	186	203
	20	152	176
GO, 180°C ^[3]	10 mV/s	175	226
	20 mV/s	152	215
GO, ethylene diamine, hydrazine, 90°C ^[4]	1	144, 191, 232	203
GO, 180°C, followed by hydrazine reduction ^[5]	1	205	203
GO, ethylene diamine, 180°C ^[6]	20	120	176
GO, hydroquinone 100°C ^[7]	1	441, 211 (without hydroquinone)	203
GO, hydrazine, NH ₃ , 95°C ^[8]	1	215	203

Reference

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